

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	) Group Art Unit: 1753
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Naoki Komai, et al.	) Confirmation No.: 3159
	)
Application No. 10/775,935	)
	)
Filed: February 10, 2004	)
	) Examiner: Luan V. Van
For: SEMICONDUCTOR MANUFACTURING	)
APPARATUS AND METHOD FOR	)
MANUFACTURING SEMICONDUCTOR	)
DEVICES	)

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**RESPONSE TO APRIL 23, 2007 OFFICE ACTION**

Dear Sir:

This Amendment is submitted in response to the Office Action mailed April 23, 2007. Applicant respectfully requests reconsideration of the application in view of this amendment and remarks herein.